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Response
5-15-03
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Antonio L. P. Rotondaro
Serial No: 10/001,483 ✓
Examiner: Michelle Estrada
Filed: 11/01/2001 ✓
For: METHOD TO IMPROVE THE UNIFORMITY AND REDUCE THE SURFACE ROUGHNESS
OF THE SILICON DIELECTRIC INTERFACE

Docket No: TI-31133
Conf. No: 1903
Art Unit: 2823

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 5-9-03.

Ann Trent
Ann Trent

Dear Sir:

Responsive to the Office Action mailed February 10, 2003, in connection with the above identified application, Applicant respectfully submits the following remarks.

TECHNOLOGY CENTER 2800
MAY 13 2003
COMM-F